

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

In re Patent Application of:)
Masahiro Tada) Group Art Unit: **2812**
Application No. **10/551,271**) Examiner: Not Yet Assigned
Filed: September 28, 2005)
For: **PROCESS FOR FABRICATING**)
MICROMACHINE)
)

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SIR:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-SB08A form, in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent. These references were cited in an Office Action issued on August 5, 2008, in connection with Japanese application no. JP2004-068325.

Copies of the foreign references and machine translations are attached as is a copy of the Japanese office action.

Respectfully submitted,

/David R. Metzger/ (Reg. No. 32,919)

David R. Metzger
SONNENSCHEIN NATH & ROSENTHAL LLP
P.O. Box 061080
Wacker Drive Station, Sears Tower
Chicago, IL 60606-1080
Telephone: 312/876-8000
Fax: 312/876-7934